### **INCLINOMETER**

MEMS technology tilt sensor







### **CHARACTERISTICS**



#### **ADVANTAGES**

MEMS technology

High protection level and wide temperature range

High temperature stability

Resolution up to 0.01°

Single axis range ±180° or 0 ... 360°

Dual axis range up to  $\pm 85^{\circ}$ 

Gyro-compensated

Excellent accuracy

Reliability and long service life for outdoor applications

Compact dimensions

Designed for harsh environmental conditions



High protection level



Shock/vibration resistant



Redundancy output



Reverse polarity protection



Wide temp. range



CANopen output



CANopen Safety



MEMS sensors technology



X,Y Horizontal version



Vertical version



High accuracy



High repeatability



Directive 2011/65/EU



EU conformity

# TLP300 CANopen INCLINOMETER

MEMS technology tilt sensor





An inclinometer measures the angle to the direction of the gravity in one or more axes.

TLP300 is the new family of inclination sensors, based on the MEMS technology, capable of working in extreme conditions and hard environments, subjected to sharp movements, shocks and high vibrations.

The perfect synthesis of precision, stability, robustness and cost, which make it suitable for use on mobile devices and applications such as: cranes, aerial platforms, operating and earth moving machines.

The integration of accelerometers and gyroscopes with sensor fusion proprietary algorithms, ensure high performances over all the operating range.









**Agricultural** machinery



Construction



Earth moving



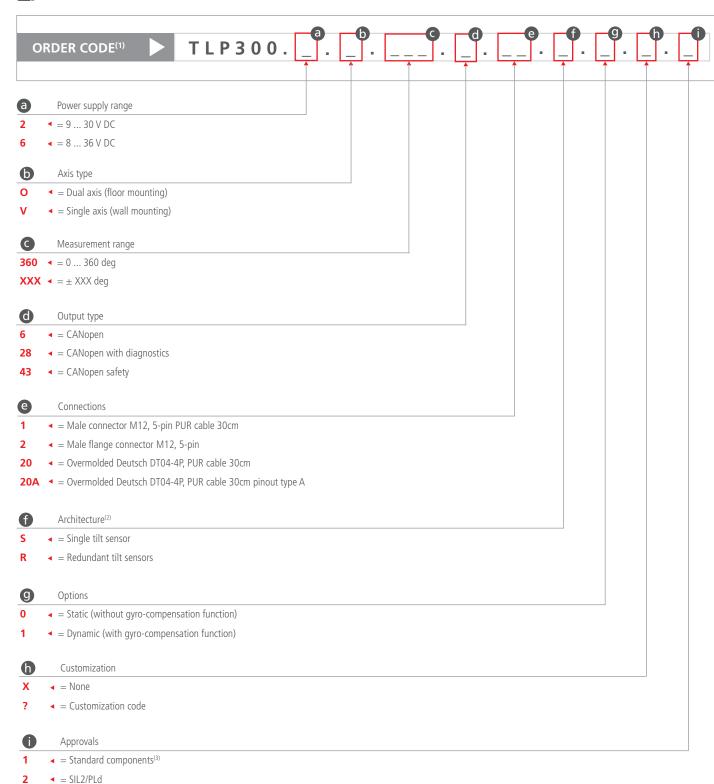
Handling and lifting

#### **INCLINOMETER**

MEMS technology tilt sensor







- (1) Not all combinations can be ordered. Please contact TSM for confirmation before placing an order.
- (2) Redundanted primary measures, acquired by a single logical unit and published on the CANOpen output by one or more PDOs, according to the selected mapping.
- (3) MTTFd > 100 years (EN ISO 13849-1) a) b)
  - a) Standard component. It does not constitute a safety component as defined in the Machinery Directive 2006/42/CE.
  - b) Every second failure of an electronic component is regarded as a dangerous failure.

The company reserves the right to make any kind of design or functional modification at any moment without prior notice.

#### **INCLINOMETER**

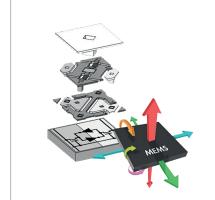
MEMS technology tilt sensor



### **(2)**

#### **TECHNICAL SPECIFICATION**

Measuring range	Up to ±85° for dual axis type ±180° and 0 360° for single axis type
Accuracy (Ta = 25 °C)	±0.3°
Resolution	0.01°
Temperature drift	±0.01 °/°C typ.
Protection class	IP67 (acc. to EN 60529)
Temperature range	-40°C +85°C
Housing	Glass fiber reinforced polyamide
Weight approx.	70 g
Shock resistance	acc. to EN 60068-2-27 50 G, 11 ms, 100 shocks per axis Axis : X, Y, Z
Vibration resistance	acc. to EN 60068-2-6 10 500 Hz, 10g, 2h per axis Axis : X, Y, Z



OPERATING PRINCIPLE

MEMS, or Micro Electro-Mechanical System, is a

chip-based technology where sensors are composed of proof masses sprung between capacitive plates. Each mass act like a moving plate of a variable capacitor formed by an array of

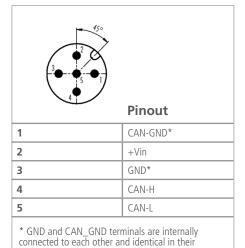
when the sensor is tilted, the mass moves changing the distance between the plates and therefore the capacitance. By measuring the capacitance variation the angle value can be detected.



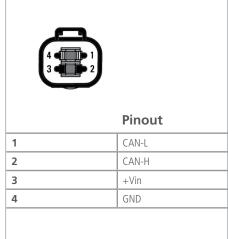
#### **ELECTRICAL CHARACTERISTICS**

Power supply range	See order code
Consumption typ.	30 mA (12 VDC, w/o load) 15 mA (24 VDC, w/o load)
Startup time	< 1.5 s
Interface	CANopen CANopen safety
CANopen profile conformity	CiA DS301
EMC compatibility (Industrial electromagnetic environment)	acc. to EN 61326-1, EN 61326-3-1
EU conformity	EMC directive 2014/30/EU RoHS directive 2011/65/EU + 2015/863/EU

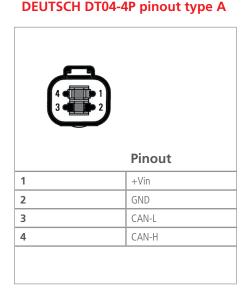
## 1 & 2] ELECTRICAL CONNECTION M12 X 5 PINS



# 20] ELECTRICAL CONNECTION DEUTSCH DT04-4P



### 20A] ELECTRICAL CONNECTION



### **INCLINOMETER**

MEMS technology tilt sensor





#### **COUNTING DIRECTION**

### **Dual axis**



#### TLP300 dual axis inclinometer

The 2-dimensional tilt sensor must be mounted with the base plate in horizontal position, i.e. parallel to the horizontal line. The sensor can be tilted to both the X and Y axes at the same time.

A separate measure is provided for each axis.









### Single axis



#### TLP300 single axis inclinometer

The 1-dimensional tilt sensor must be installed with the base plate in vertical position, i.e. Z-axis perpendicular to the force of gravity.

The default "zero point" position is the one shown in the following images.









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